

INFORMATION DISCLOSURE CITATION (Use several sheets if necessary) Page 1 of 1 PTO Form 1449	Attorney Docket No. 46884-5518	Serial No. 10/594,892
	Applicant(s): Takeshi SAKAMOTO, et al.	
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U.S. PATENT DOCUMENTS

*Examiner Initial	Document Number	Date	Name	Class	Sub Class	Filing Date

FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Sub Class	Translation	
							YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)	
	Hayashi, K. "Inner Glass Marking by Harmonics of Solid-State Laser", Proceedings of 45 th Laser Materials Processing Conference, December 1998, pgs. 23-28.
	Miura, K. et al. "Formation of Photo-Induced Structures in Glasses with Femtosecond Laser", Proceedings of 42 nd Laser Materials Processing Conference, November 1997, pgs. 105-111.
	Sano, T. et al. "Evaluation of Processing Characteristics of Silicon with Picosecond Pulse Laser", Preprints of the National Meeting of Japan Welding Society, No. 66, April 2000, pgs. 72-73 (with corresponding English-language translation).
Examiner	Date Considered
Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	